

Search Notes

Application/Control No.

10/671,349

Examiner

Arnel C. Lavarias

Applicant(s)/Patent under
Reexamination

KIRCHHUEBEL, RAINER

Art Unit

2872

SEARCHED

Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Consulted with Thong Nguyen regarding restriction requirement	9/29/2005	ACL